

F i g . 1

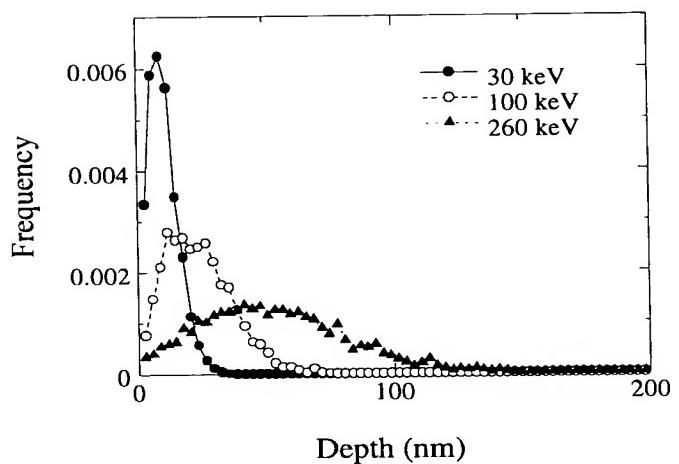
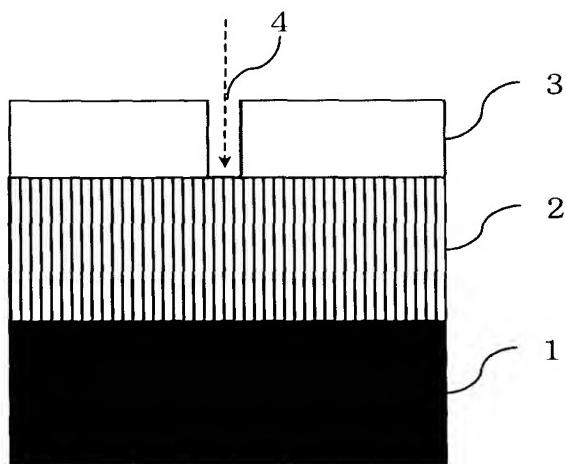
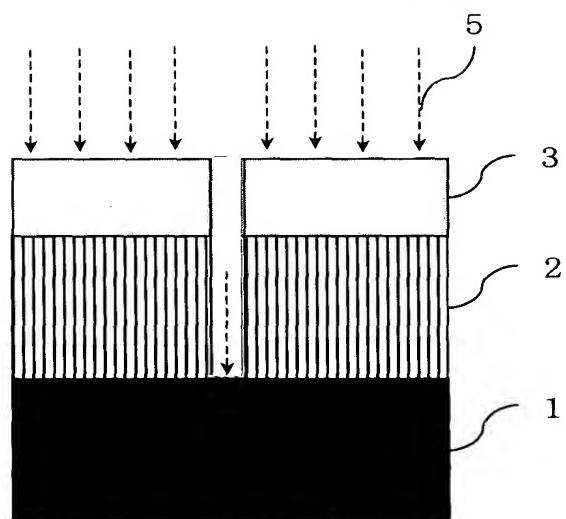


Fig. 2

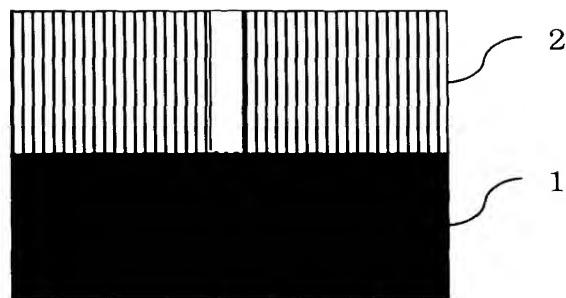
(a)



(b)



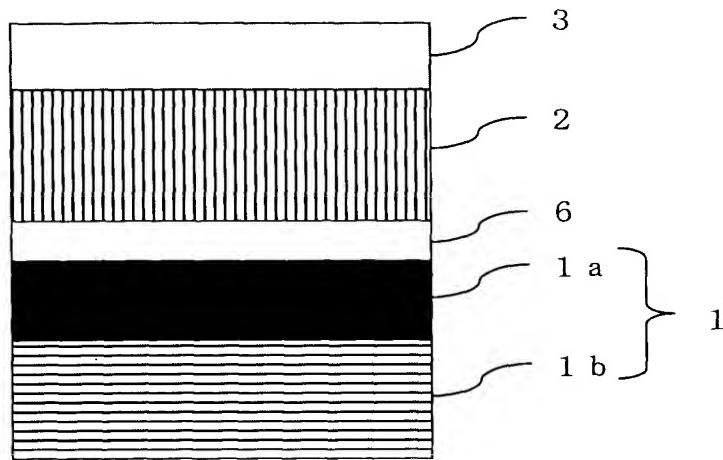
(c)



Title: METHOD OF  
MANUFACTURING NANO-GAP  
ELECTRODE  
Inventor(s): Takashi NAGASE et. al.  
Appl. No.: Unassigned

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F i g . 3



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F i g . 4

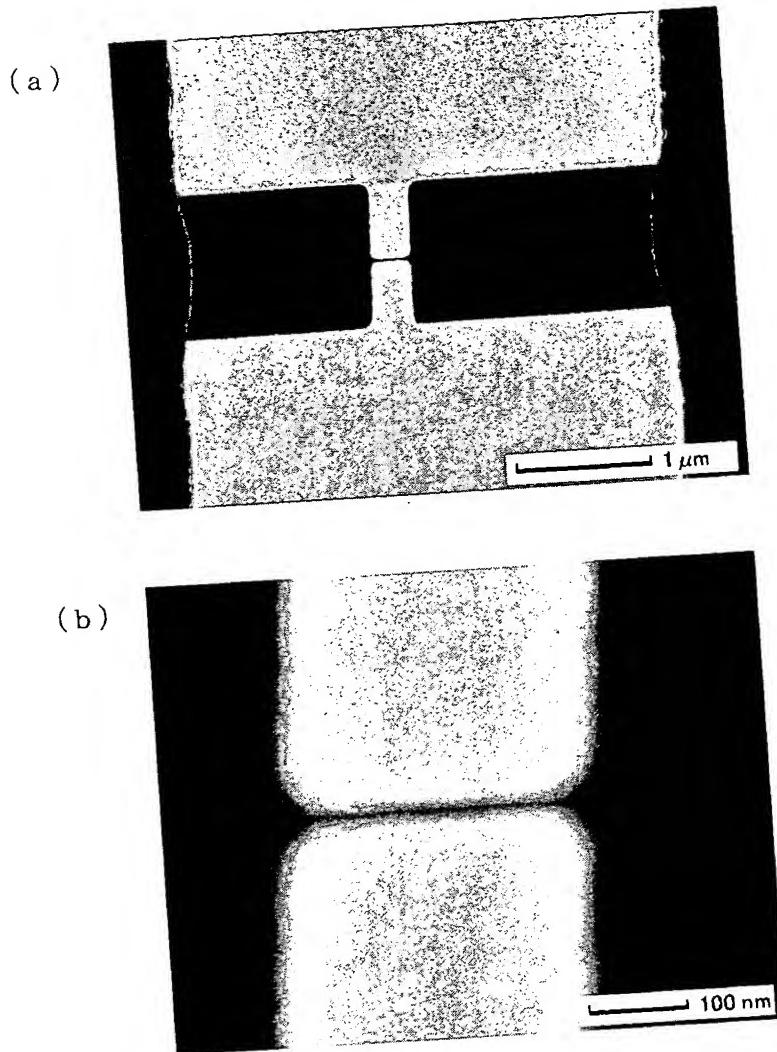


Fig. 5

